



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Lee Docket No.: 2003 P 50816 US
Serial No.: 10/600,661 Art Unit: TBD
Filed: June 20, 2003 Examiner: TBD
For: Magnetic Tunnel Junction Patterning Using SiC or SiN

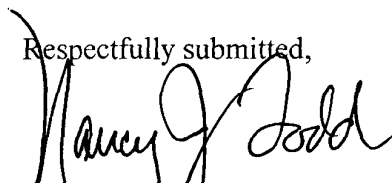
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Date of Deposit: July 16, 2003

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Respectfully submitted,


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